## UBC PHYS 560-201, UVic PHYS 522 Physics and Engineering of Particle Accelerators in 2023

#### **Overview:**

A 3 credit points course open to domestic and international students, offered by the UBC and UVic Physics Departments in partnership with TRIUMF.

#### Dates, times, location:

Course duration: Jan. 10 to April 11, 2023 – mid-term break Feb. 20-24, 2023 Course times: Tuesdays and Thursdays 14:00-15:30 PST Course location: MOB conference room at TRIUMF and online via Zoom

## Brief summary of the synopsis:

The course will provide an introduction to the physics, technology and some engineering aspects of particle accelerators with focus on proton and ion accelerator technology. The course will include a survey of existing accelerator types and an introduction to transverse and longitudinal beam optics. The course will also include an introduction to the physics and technology of ion sources, will give an overview of secondary particle production with focus on radioactive ion beam production, of accelerator radio-frequency principles and more detailed aspects of room temperature and superconducting linear accelerators, as well as high energy circular machines. The course should appeal to students of Accelerator Physics and Physics Engineering, as well as to students of Experimental Nuclear and Particle Physics and other students interested in Particle Accelerators.

## **Pre-requisites:**

Classical Mechanics, Classical Electro-dynamics

## Lecturers:

The course will be given by a team of lecturers made up of experts from the TRIUMF Accelerator Division and UVic. Each lecturer is responsible for about 3-5 lectures.

## **Final Grade:**

Weekly homework (due one week after assignment) – 50% (based on completion and quality) Mid-term exam (March 01, 2022) – 20% Final Exam (TBA) – 30%

## **Course Coordinator:**

Oliver Kester, TRIUMF okester@triumf.ca

# Course outline and lecture synopsis:

Lecture	Date	Lecturer		
1	January 10	Rick Baartman baartman@triumf.ca		
Title: Historical overview Linear and Circular accelerators				
Synopsis: Introduction of the basic principles of acceleration and a review of the historical development of accelerators, both linear and circular.				
2	January 12	Rick Baartman baartman@triumf.ca		
Title: Cyclotrons – from Classical to Isochronous pre-reading: Livingood – Principle of Cyclic Particle Accelerators				
Synopsis: The magnetic resonance is the basis of the Cyclotron. An overview of cyclotron principles, technical solutions and applications will be shown.				
2	January 17	<b>Bick Baartman</b> baartman@triumf.ca		
Title: Basics of linear ontics	of heams - transverse heam dy			
Synonsis:		And mes		
Hill's equation, Matrix formalism and beam focusing will be explained.				
4	January 19	Thomas Planche <u>tplanche@triumf.ca</u>		
Title: Beam emittance and TWISS parameters, particle distributions				
Synopsis: Coordinate system (Frenet-Serret coordinate systems) and the concept of beam emittance and phase space is addressed in this lecture. Examples of particle distribution and their beam emittance, as well as the description of the beam emittance via Courant Snyder ellipse concept will be explained.				
5	January 24	Thomas Planche tplanche@triumf.ca		
Title: Basics of longitudinal b	beam dynamics			
Synopsis: The Equation of motion for particles in the longitudinal direction will be derived. The longitudinal phase space including the separatrix will be introduced. The principle of phase focusing and transit time factor (TTF) will be addressed.				
6	January 26	Thomas Planche tplanche@triumf.ca		
Title: Beam line elements - N	Aagnets (Design and function)			
Synopsis: Magnetic elements are key for particle accelerators and beam line systems. The beam physics sets the requirements for the design of such elements. The electromagnetic principles for dipoles and multipoles of normal and superconducting magnets will be explained.				

•	January 31	Thomas Planche <u>tplanche@triumf.ca</u>			
Title: Physics of space charg	e dominated beams				
Pre-reading:					
Synopsis:					
By transporting charged particles, all of like charge, they naturally repel each other and he repulsion					
forces can at highest intensi	ities be comparable to the foc	using forces of beam line elements, so must			
be taken into account. The	space charge fields of a beam	will be presented including relativistic			
beams. The effect of space	charge forces on beam envelo	pe and emittance is explored.			
8	February 2	Friedhelm Ames ames@triumf.ca			
Title: Introduction to electro	on and ion sources				
Pre-reading: Ian G. Brown –	The Physics and Technology o	f Ion Sources			
Synopsis:					
The basics of electron emiss	sion processes and ionization v	vill be explained. This will include thermionic			
emission, photo emission ar	nd electron impact ionization.	Some examples for electron and ion sources			
will be presented.					
9	February 7	Friedhelm Ames <u>ames@triumf.ca</u>			
Title: Plasma physics and ma	agnetic confinement				
Synopsis:					
Electron and ion beam form	ation will be introduced. Plasr	na physics and magnetic plasma			
confinement are key for the	operation of plasma ion sour	ces. Fundamentals from plasma physics and			
the principle of magnetic co	onfinement of plasma will be a	ddressed. The extraction of ions from a			
nlasma will be discussed in more details					
	nore details.				
10	February 9	Friedhelm Ames ames@triumf.ca			
<b>10</b> Title: Plasma ion sources for	February 9	Friedhelm Ames <u>ames@triumf.ca</u>			
<b>10</b> Title: Plasma ion sources for Synopsis:	February 9 r positive and negative ions	Friedhelm Ames <u>ames@triumf.ca</u>			
<b>10</b> Title: Plasma ion sources for Synopsis: Due to the different types o	February 9 r positive and negative ions f plasma generation (discharge	Friedhelm Ames <u>ames@triumf.ca</u> e, RF, laser) and different strategies of			
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13	March 2	Thomas Day Goodacre		
Title Physics of radioisotope	production	tdaygoodacre@triumt.ca		
Pre-reading: Introductory Nuclear Physics, Kenneth S. Krane, Chapters 1, 3.1, 3.2, 3.3,				
Synopsis: The basics of interactions of beams with matter will be discussed. The nuclear physics to understand the occurring nuclear reactions that generate secondary particles in accelerator targets will be introduced and their consequences on target design and operation parameters discussed.				
14	March 7	Thomas Day Goodacre tdaygoodacre@triumf.ca		
Title: Accelerator based secondary particle production				
Synopsis: The introduction to methods for producing short-lived radioisotopes beams, in-flight separation and Radioisotope Separation Online (ISOL) techniques is foreseen as well as techniques for ion beam purification and selection. An overview of accelerator driven secondary particle production is reviewed in this lecture. The according beam production and target handling technology will be introduced using examples.				
15	March 9	Thomas Day Goodacre		
Title: Target and ion cources		tdaygoodacre@triumf.ca		
Synopsis:				
An overview of target materials and target technology for the production of radioisotopes for science, medicine and industry will be given. Chemically selective and high-efficiency ion sources for secondary ion beams are reviewed.				
16	March 14	Oliver Kester okester@triumf.ca		
Title: Beam Instrumentation				
Synopsis: Beam instrumentation and diagnostics is the observation of particle beams with the precision required to tune, operate, and improve the accelerators and their associated transfer lines. The lecture will introduce basic principles of beam diagnostics, destructive or non-destructive for the beam and examples of such beam.				
17	March 16	Oliver Kester <u>okester@triumf.ca</u>		
Title: Synchrotrons and Stora	age Rings			
Synopsis: The concept of storage rings, synchrotrons and colliders will be explained. The principle of periodic focusing structures will be explained, with the example the FODO lattice. Examples of storage rings and colliders will be discussed, in particular the Large Hadron Collider (LHC). Beam cooling mechanisms will be addressed.				
18	March 21	Oliver Kester okester@triumf.ca		
Title: Numerical simulation of	of charge particles in electrom	agnetic fields		
Synopsis: Basics of numerical simulations of electric and magnetic fields and electromagnetic fields in cavities are presented. In addition, basics of numerical integration of the trajectories of charge				

particles in electromagnetic fields are explained. The conceptual treatment of space charge using a self-consistent iterative approach will be addressed.

19	March 23	Robert Laxdal lax@triumf.ca		
Title: Waveguides and cavities				
Pre-reading: Thomas P. Wangler – RF-Linear Accelerators				
Synopsis:				
The key infrastructure elements supporting RF-acceleration are wave guides and RF-resonators or				
cavities. The fundamentals of wave guides, cavities and standing electromagnetic waves in such				
devices will be discussed.				
20	March 28	Robert Laxdal <u>lax@triumf.ca</u>		
Title: Fundamental parameters of RF resonators (Q-value, shunt impedance, skin depth, surface resistance)				
Synopsis:				
The physics of RF-resonators	s and the fundamental parame	eters of normal and superconducting		
cavities will be reviewed in t	his lecture.			
21	March 30	Robert Laxdal <u>lax@triumf.ca</u>		
Title: RF acceleration in periodic structures – Linear Accelerators				
Synopsis:				
RF-acceleration in linear acc	elerators (linacs) is introduced	l as well as basic parameters are discussed.		
Different types of linacs are	introduced as examples to de	monstrate the principles.		
22	April 4	Robert Laxdal <u>lax@triumf.ca</u>		
Title: Hadron accelerators: Radio Frequency Quadrupoles (RFQ), IH-structures, DTLs, SRF cavities				
Synopsis:				
A review of hadron linear accelerators including RFQs, IH-structures, Alvarez and coaxial cavities and				
the major operational variants of these structures: pulsed vs CW operation and normal conducting vs				
SRF technologies.				
23	April 6	Tobias Junginger junginger@uvic.ca		
Title: Modern concepts of ultra-high gradient acceleration				
Synopsis: Present concepts and the future of SRF, Laser Plasma Acceleration and Wake field				
Synopsis: Present concepts	and the future of SRF, Laser P	lasma Acceleration and Wake field		